

Attorney's Docket No.: 07977-017002
Client's Ref. No.: US2968C1D1

OFFICIAL COMMUNICATION

FACSIMILE

FOR THE PERSONAL ATTENTION OF:

EXAMINER LAURA SCHILLINGER

GROUP 2813 FAX NO: 1-703-872-9319

Number of pages including this page 8

Applicant : Yamazaki, et al.
Serial No. : 09/451,665
Filed : November 30, 1999

Art Unit : 2813
Examiner : Laura Schillinger
Confirmation No. : 9359

Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF
FACSIMILE COMMUNICATION

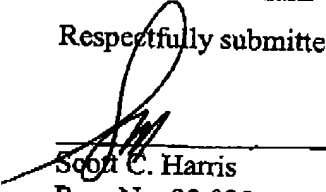
Commissioner for Patents
Washington, D.C. 20231

Sir:

Attached to this facsimile communication cover sheet is an Amendment, faxed this 23rd day of September, 2002, to Group 2813, the United States Patent and Trademark Office.

Respectfully submitted,

Date: September 23, 2002


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TECHNOLOGY CENTER 2800

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Attorney's Docket No.: 07977/017002/US2968C101

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Commissioner for Patents
 Washington, D.C. 20231

September 23, 2002
 [Note: September 21, 2002
 was a Saturday]

AMENDMENT

In response to the Official Action dated May 21, 2002,
 Paper No. 12, in the above-referenced application, kindly amend
 the above-identified application as follows.

In the Claims:

Please amend the claims as follows.

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1. (Amended) A method of manufacturing a semiconductor device
 comprising the steps of:

forming a crystalline semiconductor film on an insulating
 surface;

CERTIFICATE OF TRANSMISSION BY FACSIMILE

I hereby certify that this correspondence is being transmitted by
 facsimile to the Patent and Trademark Office on the date indicated
 below.

September 23, 2002
 Date of Transmission

Signature

Susan Regan
 Typed or Printed Name of Person Signing Certificate